



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

## ELECTRONIC COPY

### LABORATORY GROWN DIAMOND REPORT

January 22, 2025

IGI Report Number **LG665403603**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **6.97 X 4.72 X 3.10 MM**

#### GRADING RESULTS

Carat Weight **0.99 CARAT**

Color Grade **F**

Clarity Grade **VS 1**

#### ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **VERY GOOD**

Fluorescence **NONE**

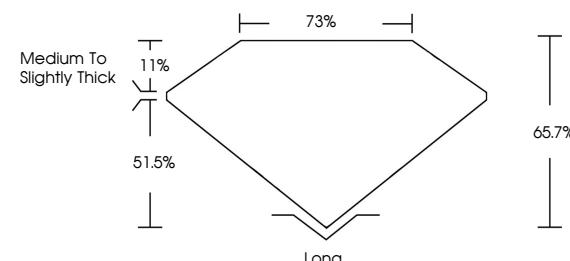
Inscription(s) **IGI LG665403603**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa

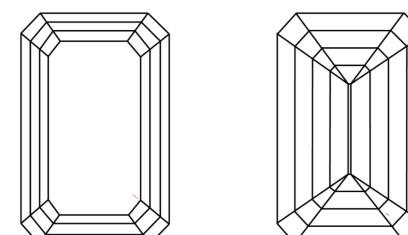
LG665403603  
Report verification at [igi.org](http://igi.org)

#### PROPORTIONS



Sample Image Used

#### CLARITY CHARACTERISTICS



#### KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

[www.igi.org](http://www.igi.org)

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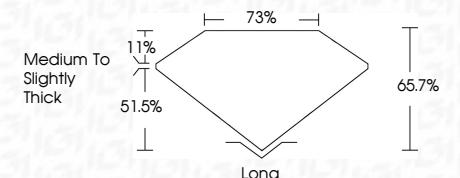
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January 22, 2025	IGI Report No LG665403603	EMERALD CUT	6.97 X 4.72 X 3.10 MM	0.99 CARAT	F	VS 1	65.7%	73%	Medium To Slightly Thick	Long	EXCELLENT	VERY GOOD	NONE	IGI Generation

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Type IIa